

<b>Notice of References Cited</b>	Application/Control No. 10/626,767	Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner David Y. Chung	Art Unit 2871	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,034,339	07-1991	Tanaka et al.	438/158
*	C	US-5,034,340	07-1991	Tanaka et al.	438/158
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*	E	US-5,065,202	11-1991	Tanaka et al.	257/59
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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